

Citations for Ion : **Tm**

<i>Pub. Year</i>	<i>Authors, Title, Journal Citation and Comments</i>	<i>Citation Numb</i>
1975	Kiselevich, M. Lyatushinski, A. Zhuk, V. Osipenko, B. P. 'Implantation of Heavy Ions into Silicon Single Crystals' <i>Fiz. Tverd. Tela, 17, 1080-84 (1975). [Engl. Trans. Sov. Phys. Solid State, 17, 687-89 (1975).</i> <i>Comment : R, dR. 45 keV Sr, Ba, Ce, Nd, Eu, Gd, Tb, Er, Tm, Lu -> Si (Cryst. Chann. And Random)</i>	1975-Kise
